



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG619440002

Report verification at igi.org

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February 2, 2024
IGI Report Number **LG619440002**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **11.51 X 7.38 X 4.59 MM**

GRADING RESULTS

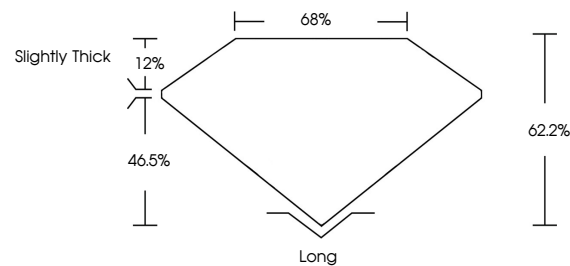
Carat Weight **4.10 CARATS**
Color Grade **E**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

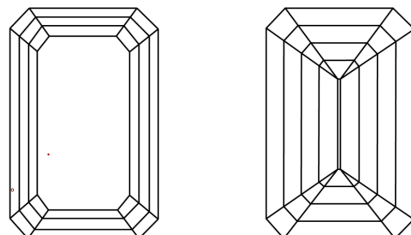
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG619440002**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

GRADING SCALES

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

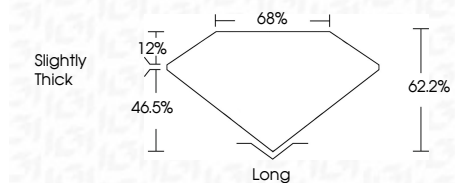
COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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Sample Image Used



IGI

February 2, 2024
IGI Report No LG619440002
EMERALD CUT
11.51 X 7.38 X 4.59 MM
4.10 CARATS
Color Grade **E**
Clarity Grade **VVS 2**
Depth **62.2%**
Table **68%**
Girdle **Slightly Thick**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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